Searcn Notes				

Application/Control No.	Applicant(s)/Patent under Reexamination
10/026,172	FUJISAWA ET AL.
Examiner	Art Unit
Pierre-Louis Desir	2681

SEARCHED				
Class	Subclass	Date	Examiner	
455	88	6/6/2005	PD	
368	13	3/5/2006	PD	
702	179	1/31/2006	PD	
340	5.61	1/31/2006	PD	
360	10	1/31/2006	PD	
702	179	1/31/2006	PD	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		,		
	1			

SEARCH NOT (INCLUDING SEARCH		
	DATE	EXMR
EAST	5/31/2005	PD
EAST	6/2/2005	PD
EAST	6/3/2005	PD
EAST	1/31/2006	PD
EAST	3/5/2006	PD